

COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE P.O. BOX 1450

WITHDRAWAL FROM

ISSUE

MAR - 7 2007

In re Application of

Junichi Ueno

Serial No. 10/549,453

September 14, 2005 Filed:

For:

WAFER-HOLDING CARRIER,

DOUBLE-SIDE POLISHING APPARATUS: USING THE SAME, AND DOUBLE-SIDE:

POLISHING METHOD OF WAFER

The purpose of this communication is to inform you that the above-identified application is being withdrawn from issue pursuant to 37 CFR 1.313.

The application is being withdrawn to permit reopening of prosecution. The reasons therefor will be communicated to you by the examiner.

PTO records reveal that the issue fee has not been paid. If the issue fee has been submitted, the applicant may request a refund or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Issue Fee Due, applicant may request that the previously submitted issue fee be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due. If the application is abandoned, applicant may request either a refund or a credit to a deposit account.

The application is being forwarded to the examiner for prompt action.

Mederick R. Schmidt, Director

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